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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

TAKAHASHI et al

Atty. Ref.: 829-585; Confirmation No. 1578

Appl. No. 09/936,818

TC/A.U. 1722

Filed: September 18, 2001

Examiner: Song

For: CRYSTAL GROWTH METHOD, PRODUCTION METHOD OF SEMICONDUCTOR

MICROSTRUCTURE, SEMICONDUCTOR DEVICE AND SYSTEM

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April 24, 2006

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

RESPONSE AFTER FINAL

Responsive to the Official Action dated January 23, 2006, reconsideration is respectfully requested for at least the following reasons.